

Application Serial No. 10/555,141
Amendment dated October 16, 2006
Reply to Office Action dated July 12, 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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|-------------------|---|--|------------------|------|
| Appl. No. | : | 10/555,141 | Confirmation No. | 2898 |
| Applicant | : | Alexander Hauser et al. | | |
| Filed | : | October 31, 2005 | | |
| Title | : | METHOD FOR TEXTURING SURFACES OF SILICON WAFERS | | |
| TC/A.U. | : | 2812 | | |
| Examiner | : | Mohsen Ahmadi | | |
| Atty. Docket No.: | | RAC0082 | | |
| Customer No. | : | 0832 | | |

AMENDMENT AFTER FINAL

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action of July 12, 2006, having a period for response set to expire on October 12, 2006, which period has been extended for one (1) month to November 12, 2006, please amend the above-identified application as follows.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 4 of this paper.